Supplementary Information for

On-chip integration of metal-organic framework nanomaterial on SiO_2 waveguide for sensitive VOC sensing

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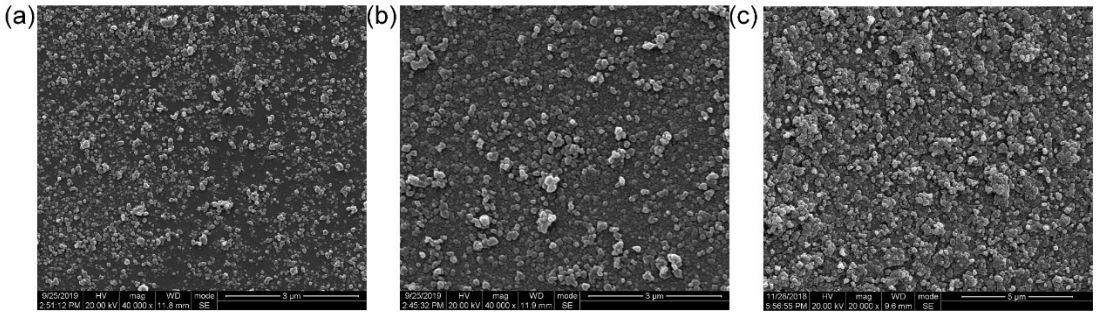

Fig. S1 SEM of ZIF-8 on silicon dioxide substrate. (a) 2 cycles; (b) 4 cycles; (c) 8 cycles.

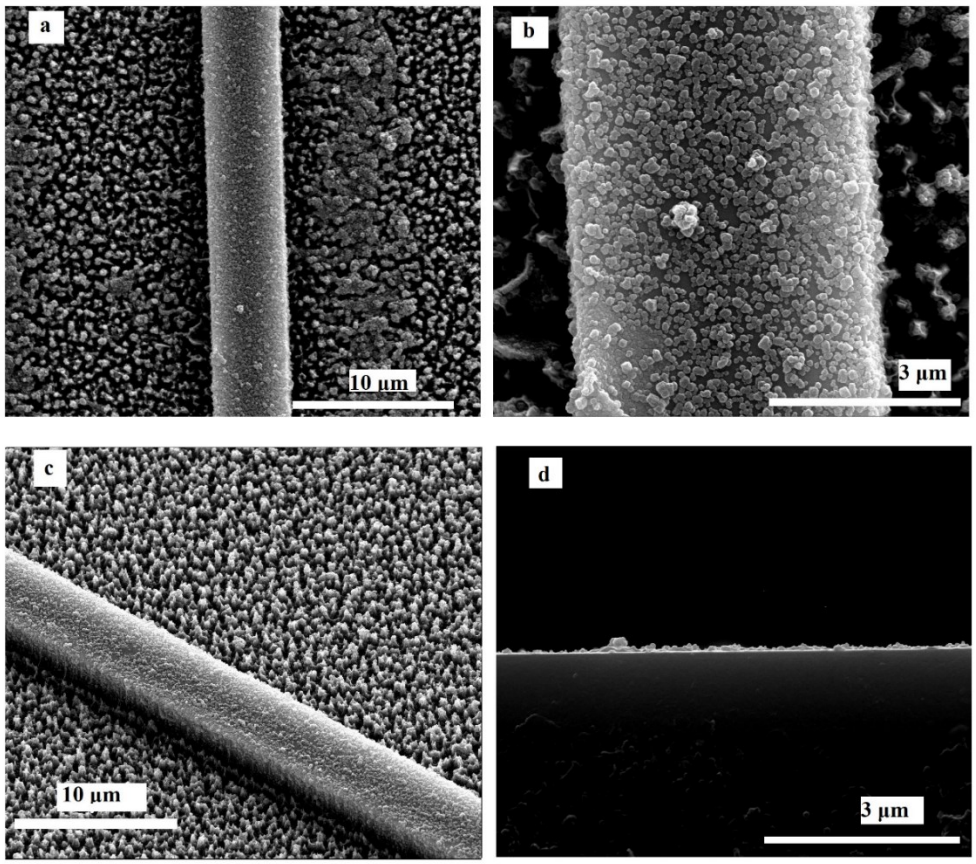

Fig. S2 Surface morphology of strip waveguide (using etching recipe-1) after 8 cycles of ZIF-8 self-assembly

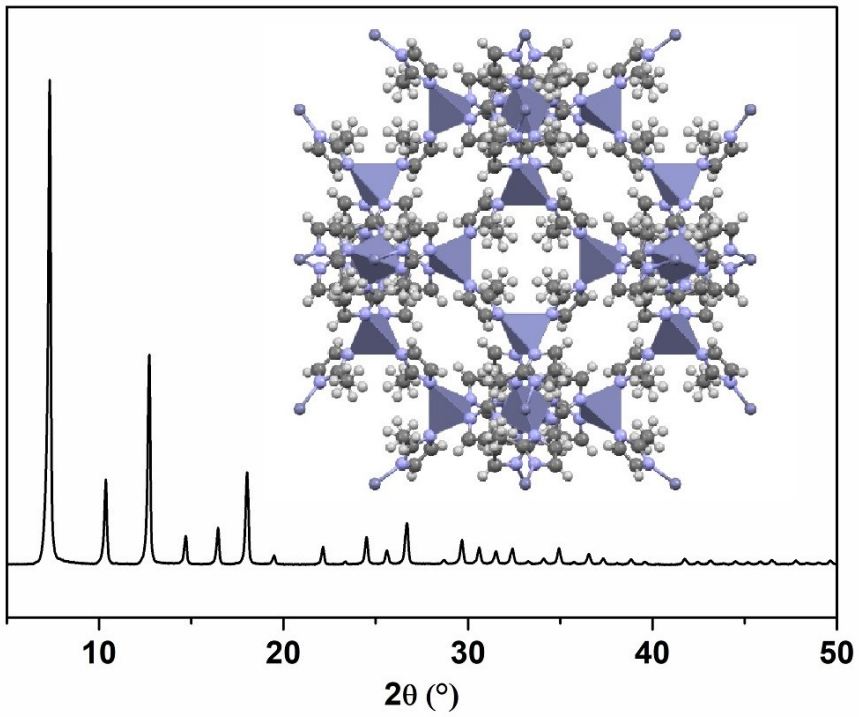

Fig. S3 Powder XRD of ZIF-8 (inset: three-dimensional configuration of ZIF-8)